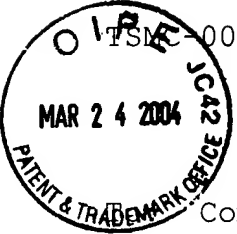


Imafe

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TSMC-00-166

February 23, 2004

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Fr: George O. Saile, Reg. No. 19,572
28 Davis Ave
Poughkeepsie, NY 12603

Subject: | Serial No. 09/679,514 10/06/00 |
| Hung-Jen Hsu |

"A METHOD TO IMPROVE PASSIVATION
OPENINGS BY REFLOW OF PHOTORESIST
TO ELIMINATE TAPE RESIDUE"

Grp. Art Unit: 2823 B. KEBEDE

RESPONSE PATENT OFFICE ACTION

Dear Sir:

In response to the Office Action dated January 21, 2004,
please consider the following remarks concerning the above-
identified application for patent:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being
deposited with the United States Postal Service as first
class mail in an envelope addressed to: Commissioner for Patents
P.O. Box 1450, Alexandria, VA 22313-1450, on March 22, 2004,
2003.

Stephen B. Ackerman, Reg. No. 37,761

Signature *SB Ackerman*
Date 3/22/04